

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Yuichi KAWANO et al.

Application No.: 10/582,983

Confirmation No.: 8160

Filed: January 5, 2007

Art Unit: 1763

For: PLASMA PROCESSING APPARATUS

Examiner: V. Bernard

REPLY UNDER 37 C.F.R. § 1.111

MS AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated June 28, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

- Amendments to the Specification;
- Amended Claim Set;
- Remarks;
- Substitute Specification; and
- Comparison Specification.